

## Adsorption-Controlled Growth of SrTiO<sub>3</sub> by Oxide MBE

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Historically, the growth of stoichiometric SrTiO<sub>3</sub> by conventional molecular-beam epitaxy (MBE), utilizing elemental sources, has been challenging due to the precise calibration required. It would be useful if there were a thermodynamic regime where the composition of SrTiO<sub>3</sub> was self-regulating. One demonstrated way to achieve such automatic control of stoichiometry in SrTiO<sub>3</sub> is by supplying an excess of the volatile organometallic precursor titanium isopropoxide to grow SrTiO<sub>3</sub> by metalorganic MBE (MOMBE). Another means, and the one investigated here, is to stick with elemental sources but increase the substrate temperature. When SrTiO<sub>3</sub> is heated to high temperature, it does not evaporate congruently; rather, it loses more strontium than titanium. This difference in the vapor pressures of the volatile species suggests that adsorption-controlled growth of SrTiO<sub>3</sub> may be possible by conventional MBE. We report a thermodynamic window in which SrTiO<sub>3</sub> can be grown via adsorption control by conventional MBE. A new high-temperature laser substrate heater installed in Cornell University's PARADIM Thin Film Facility allows substrate temperatures to reach up to 2000 °C.

We show that the growth window for our highest quality adsorption-controlled SrTiO<sub>3</sub> is from approximately 1450-1475°C, with a Sr:Ti ratio of 5:1. All films were grown on LaAlO<sub>3</sub> (100) substrates. Figure 1 shows XRD data for samples grown at several temperatures including the adsorption-control window.

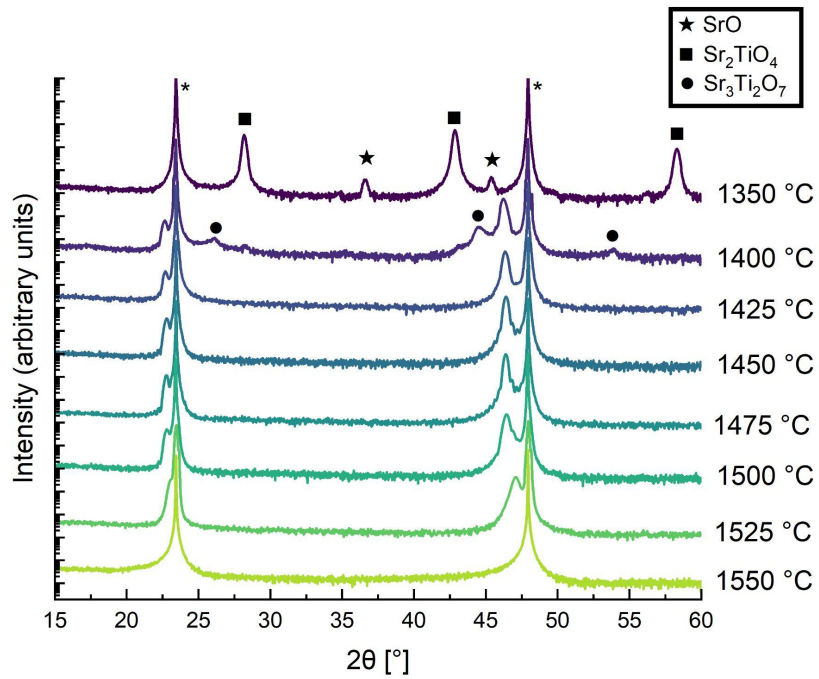


Figure 1:  $\theta$ - $2\theta$  x-ray diffraction scan showing approximately 33 nm thick films of SrTiO<sub>3</sub> grown by MBE on LaAlO<sub>3</sub> (100) at a range of temperature from 1350-1550 °C at a background pressure of 10% ozone of  $1 \times 10^{-6}$  Torr.